

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
In re Patent Application of)
Shunpei YAMAZAKI)
Application No. 10/772,586)
Filed: February 6, 2004)
For: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE)
AND DISPLAY DEVICE UTILIZING SOLUTION EJECTOR)

INFORMATION DISCLOSURE STATEMENT

United States Patent and Trademark Office
Customer Window, **Mail Stop RCE**
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. §1.56, Applicants hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98. In accordance with the policies of the U.S. Patent and Trademark Office, only copies of newly cited foreign patents and non-patent literature are being submitted.

Applicant wishes to note that Japanese Reference No. 2000-135467 with Abstract was previously cited in the Information Disclosure Statement filed December 15, 2009. Applicant herewith which to submit an English Translation of the Japanese 2000-135467.

It is requested that the accompanying PTO-1449 be considered and made of record in the above-identified application. It is respectfully requested that an Examiner initialed copy of this form be returned to the undersigned.

The Commissioner is hereby authorized to charge any fee required in connection with this filing, and any additional fees which may be required, or credit any overpayment to Deposit Account No. 19-2380.

Respectfully submitted,

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